


Search Notes 	Application/Control No. 10607020	Applicant(s)/Patent Under Reexamination HILL ET AL.
	Examiner Le Nguyen	Art Unit 2174

SEARCHED

Class	Subclass	Date	Examiner
715	752, 963	11/13/07	lvn
715	752, 963	2/25/2009	lvn
715	752, 963	6/17/2009	lvn
715	752, 963	12/30/2009	lvn
715	752, 963	5/19/2010	lvn
715	752, 963	11/4/2010	lvn

SEARCH NOTES

Search Notes	Date	Examiner
confirmed allowance w/Sy Luu	6/21/07	lvn
US-PGPub, USPAT: 715/751-753; 709/204-207	11/13/07	lvn
EPO, JPO	11/13/07	lvn
ACM library, IEEE Xplore	11/13/07	lvn
confirmed allowance w/Raymond Bayerl	6/25/07	lvn
confirmed allowance w/Steve Sax	11/26/07	lvn
updated search	2/25/2009	lvn
updated search	6/17/2009	lvn
updated search	12/30/2009	lvn
updated search	5/11/2010	lvn
updated search	11/4/2010	lvn

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner
715	752, 963	11/13/07	lvn
715	752, 963	2/25/2009	lvn
715	752, 963	6/17/2009	lvn
715	752, 963	12/30/2009	lvn
715	752, 963	5/19/2010	lvn
715	752, 963	11/4/2010	lvn

--	--